

FEE TRANSMITTAL

Electronic Version 1.1.0

Stylesheet Version: 1.0

Patent fees are subject to annual revisions on or about October 1st of each year.

Large Entity

TOTAL FEES AUTHORIZED: \$ 1508

The commissioner is hereby authorized to charge indicated processing and/or publication fees and credit any overpayments to:

Deposit Account Number: 500860



Deposit Account Name: Advanced Technology Materials, Inc.

Charge Any Additional Fee Required Under 37 C.F.R. Sections 1.16 and 1.17.

Charge Assignment Fees Required Under 37 C.F.R. Section 1.21 (h).

SUBMITTED BY

Authorized Name: Margaret Chappuis

Electronic Signature Mark: Margaret Chappuis

Date Signed: 20021001

BASIC FILING FEE

Fee Description	Fee Code	Fee Paid
Utility Filing Fee	101	\$ 740

Subtotal For Basic Filing Fee: \$ 740

EXTRA CLAIM FEES

	Fee Code	Fee	Extra Claims	Fee Paid
Total Claims: 44	103	\$ 18	24	\$ 432
Independent Claims: 7	102	\$ 84	4	\$ 336

Subtotal For Extra Claims Fees: \$ 768



TRANSMITTAL FORM

Electronic Version 1.0.3

Stylesheet Version: 1.0

Attorney Docket
Number:

ATMI-
466

Submission Type: Utility Patent
Filing

COMPOSITION AND CHEMICAL VAPOR DEPOSITION METHOD FOR FORMING ORGANIC LOW K DIELECTRIC FILMS

First Named Inventor: Mr. Neil H Hendricks

SUBMITTED BY

Name:	Ms. Margaret Chappuis
Registration Number:	45,735
Electronic Signature Mark: Margaret Chappuis	Date Signed: 20021001

I certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.

I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.

Attached Files:

specification	466spec.xml
bibd-transmittal	466subpapersapds.xml

fee-transmittal

466subpapersfee.xml

Comments:

Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only

EFS ID: 18468
Application ID: 10065302
Title of Invention: COMPOSITION AND CHEMICAL
VAPOR DEPOSITION METHOD FOR
FORMING ORGANIC LOW K
DIELECTRIC FILMS
First Named Inventor: Neil Hendricks
Domestic/Foreign Application: Domestic Application
Filing Date: null
Effective Receipt Date: 2002-10-01
Submission Type: Utility Patent Filing
Filing Type: new-utility
Confirmation Number: 0
Attorney Docket Number: ATMI-466
Digital Certificate Holder: cn=Margaret Chappuis, ou=Registered Attorneys, ou=Patent and
Trademark Office, ou=Department of Commerce, o=U.S.
Government, c=US
Certificate Message Digest: g+MR9eKAgZdAAueLNmcKcQ==
Total Fees Authorized: \$1508.0
Payment Category: DA - Deposit Account
Deposit Account Number: 500860
Deposit Account Name: Margaret Chappuis